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Atty. Dkt. No. 039262-0115

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tadahiro OHMI et al.

Title: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Appl. No.: 10/725,063

Filing Date: December 2, 2003

Examiner: Remmon R. Forde

Art Unit: 2826

RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Mail Stop NON-FEE AMENDMENT
 Commissioner for Patents
 PO Box 1450
 Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action dated January 4, 2005, Applicants hereby elect Group II (Claims 25-76), drawn to a method of making a semiconductor device, for prosecution in the subject application, in order to advance the prosecution of this application.

Applicants, of course, reserve the right to file a divisional application covering the subject matter of the non-elected claims.

Receipt of the initial Office Action on the merits is awaited.

Respectfully submitted,

Date: January 28, 2005

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